Bi-directional of a Built-in Test Circuit for Interconnect Defects in Assembled PCBs

by Artikel 3

Submission date: 17-Jan-2024 11:00AM (UTC+0700)

Submission ID: 2272320684

File name: Bi-directional_of_a_Built-in_Test_Circuit_for.pdf (1.14M)

Word count: 2429

Character count: 11018

Bi-directional of a Built-in Test Circuit for Interconnect Defects in Assembled PCBs

Lailis Syafaah¹, Widianto¹, Hiroyuki Yotsuyanagi², Masaki Hashizume²

¹Muhammadiyah University of Malang, Indonesia.

²The University of Tokushima, Japan.

widianto@umm.ac.id

Abstract—Bi-directional of a built-in test circuit is proposed to detect open defects at inputs and outp interconnects between ICs and a PCB. The test circuit is based on an electrical characteristic of an inverter gate. A test method is related to supply current which flows to the inverter by providing a test signal to the test circuit. The test signal is generated by an AC voltage signal with a DC offset voltage. The open defects which occur at the interconnects will be detected by the large supply current flows to the inverter. On the other hand, if the defects don't occur, the supply current of the inverter is all 7st zero. Testability of the test circuit examined using a Spice simulation. The results show that the open defects at the interconnects can be detected and located.

Index Terms-Bi-directional; PCB; Spice Simulator; IC.

I. INTRODUCTION

Open defects may occur at inputs and output interconnects between ICs (integrated circuits) and a PCB (printed circuit board) [1-2]. It is a challenge to detect the defects, since many kinds of IC package type 2 re assembled on the PCB.

Boundary scan test methods have been proposed to detect the open defects by modeled it with stuck-at-faults [3-5]. The defects may not be always caused by the stuck-at-faults. Thus, it is difficult to estimate correctly which logic values will be generated by the defects which caused by the open defects fully at the interconnects.

Resistance measurements have been proposed to detect the open defects [6-7]. Resistance values will increase significantly caused by the open defect. However, the small open defects are not appropriate by the measurements.

The open defects may be detected by RF impedance analyses [8-9]. The impedance 1 lues increase in response to the open defects. However, it takes a long test time to defect the defects at high frequency operations.

We have proposed a built-in test circuit to detect the open defects [10]. Only the open defects at the input interconnects can be detected by the test circuit. Since the open defects may occur at the offput interconnects, the test circuit should be revised. Thus, we propose a new built-in test circuit in which the open defects at the inputs and the output interconnects can be detected and located.

II. BI-DIRECTIONAL OF A BUILT-IN TEST CIRCUIT

An electrical characteristic of a CMOS inverter gate is shown in Figure 1. As shown in Figure 1(b), supply current iDD of almost zero will flow to the inverter, since an input voltage of the gate Vi is either H or L level signal. If Vi is specified in Equation (1), a pMOS P1 and an nMOS N1 in

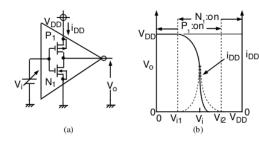


Figure 1: (a) measurement circuit; (b) DC characteristics

the gate turn on, large supply current iDD will flow to the inverter.

$$V_{i1} \le V_i \le V_{i2} \tag{1}$$

where V_{il} and V_{i2} are defined in Figure 1(b). V_{il} and V_{i2} are the minimum voltage of N_1 to be on and the maximum voltage of P_1 to be on, respectively.

A built-in test circuit TC is shown in Figure 2. A TC for an IC whose number of targeted input interconnects is Ni and targeted output interconnects is Mi, consists of (Ni+1) input buffers IB, (Mi+1) output buffers OB, a shift register SR, and Ni cells.

Each of *IB* and *OB* is made of two tristate buffers. Each *IB* is connected to an input of *SR* and to each the cell. Each *OB* is connected to an output of *SR* and to each output of a logic *core*.

The shift register *SR* is made of *Ni* D-FFs, an AND gate of two inputs, a RS-FF. *SR* is synchronized with a test clock signal *TCK* and is reset by a reset signal *RST*. An input and an output of *SR* are controlled by *IB* and *OB*, respectively.

Each of the cells consists of two multiplexers, two analog switches AS_1 and AS_2 , an nMOS switch NM_1 , and an inverter gate. AS_1 and AS_2 , and NM_1 are made of transmission gates and a pass transistor, respectively. All switches of each the cell are controlled by each the output D-FF of SR. Moreover, AS_2 of each the cell is connected to a test signal T_{sig} .

 T_{sig} is generated of an AC voltage signal V_{AC} , a DC offset voltage V_{DC} , a resistor R_S . Tsig is specified by Equation (2).

$$T_{sig} = V_{DC} + V_{AC} \sin(2.\pi f_{AC}.t)$$
 (2)

where $V_{DC} + V_{AC}$ should be in a range specified in the Equation (1) and is about half of V_{DD} . V_{AC} and f_{AC} are an amplitude and a frequency, respectively.

A test process of TC is shown in Figure 3. TC has two directions for testing all of the targeted interconnects. The directions are controlled by a test interconnect selector TIS. If a L level signal is provided to TIS, either H or L level signals are inputted to the targeted input interconnects from Di_I to Di_{Ni} and outputted to the targeted output interconnects from Do_I to Do_{Mi} , thus Di_I to Di_{Ni} will be selected to be tested. On the other hand, Do_I to Do_{Mi} will change to be tested by providing a H level signal to TIS, since either H or L level signals are inputted to the targeted output interconnects from Do_I to Do_{Mi} and outputted to the targeted input interconnects from Di_I to Di_{Ni} .

TC may select the IC works in a normal and a test mode. When a H and a L level signal are provided to test mode select TMS, the IC is in the normal mode and the test mode, respectively.

In the normal mode, supply current i_{DDS} of almost zero flows, since H or L level signals are outputted to each the cell from $cell_l$ to $cell_{Ni}$ to be propagated to the core.

In the test mode, the IC is in an initialization and to test each of the targeted interconnects. In the initialization, a L level signal is provided to *RST* and a test mode input *TMi*. To test each of the targeted interconnects, a H level signal is provided to *RST* and *TMi*.

Moreover, in the initialization, all the D-FFs of TC are initialized and generate L level signals from Q_I to Q_{Ni} . AS_I and AS_2 , and NM_I of each the cell are turned off and turned on, respectively. Supply current i_{DDS} of almost zero flows, since L level signals are generated from $cell_I$ to $cell_{Ni}$.

Further, to test each of the targeted open interconnects, a H pulse signal is generated of D-FFs from Q_I to Q_{Ni} . AS_I and AS_2 , and NM_I of each the cell are turned on and turned off, respectively. It is examined whether an open defect occurs at each of the targeted open interconnects.

In a defect-free IC, large supply current i_{DDS} of almost zero flows, since either H or L level signals are outputted from $cell_I$ to $cell_{Ni}$. When the open defect occurs at one of the targeted interconnects, an output cell of the targeted one is based on T_{sig} , thus, large supply current i_{DDS} flows and Equation (3) is satisfied.

$$i_{DDS} \ge i_{TH}$$
 (3)

where i_{TH} at threshold value and is determined by unit-tounit variations in the defect-free IC.

An assembled PCB circuit made of one more testable designed ICs may be tested using a daisy chain style shown in Figure 4. One of two directions of the test circuit is selected by a test interconnect selector *TIS*. If a L level signal is provided to *TIS*, targeted input interconnects of the ICs will be selected to be tested. Targeted output interconnects will be selected to be tested by providing a H level signal to *TIS*. An open defect which occurs at one of the targeted interconnects can be detected by means large supply current *iDDS* flows and the Equation (3) is satisfied.

III. MATH AND EQUATION EXPERIMENTAL EVALUATION USING A SPICE SIMULATION

experimental circuit is proposed to examine testability of our built-in test circuit and is made of two ICs, IC#1 and IC#2, shown in Figure 5. The ICs are designed using an SSI Spice net list library distributed by NXP Co. Ltd. Testability of the circuit is examined using a Spice simulation.

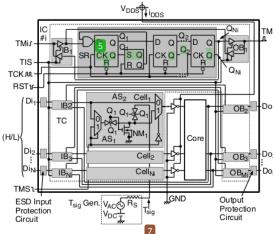


Figure 2: Bi-directional of built-in test circuit

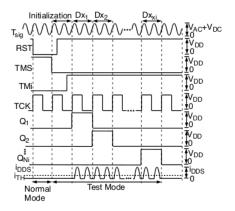


Figure 3: Test process of the test circuit

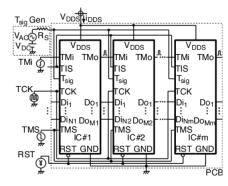


Figure 4: Daisy chain of testable designed ICs

An input interconnects of IC#2 denoted as "y" is a targeted open defect. The open defect is inserted by replacing the interconnect between x and y. Supply voltage 3.3 V is provided to V_{DDS} . A parasitic P is inserted to each the input interconnect of IC#2. P is a parasitic resistor R_P , 0.1 Ω , and a parasitic capacitor C_P , 10 pF.

Voltages of V_{DC} and V_{AC} are 0.8 V. A resistor of R_S is 2.5 k Ω . Frequencies of TCK, f_{TCK} , and Di_l , f_{Dil} , are 500 kHz. Di_2 and TMS are provided by a H level signal and a L

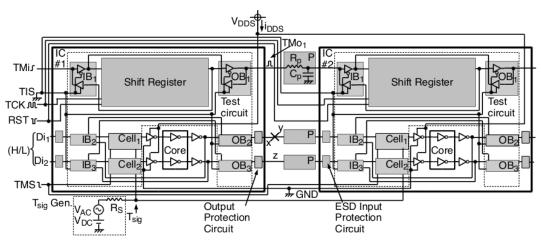


Figure 5: Experimental circuit

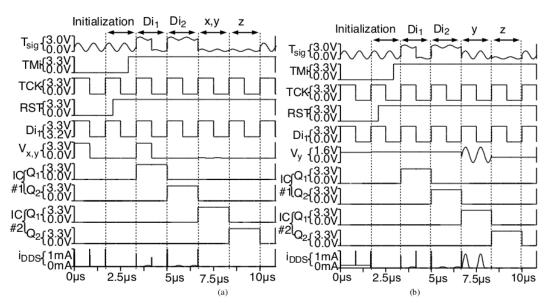


Figure 5: (a) Defect-free ICs; (b) Defective at y interconnect

level signal, respectively. A L level signal is provided to *TS* for selecting a direction that the input interconnects of the ICs will be selected to be tested.

Testability results are shown in Figure 6. The results show that the input interconnects of ICs can be selected to be tested by the direction. In Figure. 6(a) of defect-free ICs, large supply current i_{DDS} doesn't flow. The open defect at the targeted input interconnect can be detected and located by means large supply current i_{DDS} flows as shown in Figure. 6(b).



A conclusion to review the main points of the paper, do not replicate the abstract as the conclusion. A conclusion might elaborate on the importance of the work or suggest applications and extensions. Bi-directional of a built-in test circuit was proposed to detect open defects at inputs and output interconnects between ICs and a PCB. Directions of the test circuit is used to select which the interconnects will be tested. Testability of the test circuit is examined using a circuit simulation of a Spice simulator. The results show that the interconnects will be \$20cted to be tested by the directions. Furthermore, the open defects can be detected and located by the test circuit.

It remains as a future work to examt testability of resistive open defects and test speed by the test circuit.

ACKNOWLEDGMENT

This work was supported by grant PKID1411.a from Muhammadiyah University of Malang, Indonesia.

REFERENCES

- [1] Pandher, R., Pachamuthu, A., "Effect of Multiple Reflow Cycles on Solder Joint Formation and Reliability", SMTA International Conference, pp. 112-117, 2010.
 [2] Amir, D., Walwadkar, S., Aravamudhan, S., May, L., "The
- Challenges Non Wet Open BGA Solder Defect", SMTA International
- Conference, pp. 684-694, 2012.

 [3] Maunder, C.M., Tullos, R.E. "The Test Access Port and Boundary-Scan Architecture", *IEEE Computer Society Press*, 1990.

 [4] Bleeker, H., van den Eijnden, P. "Boundary Scan Test A Practical
- Approach", Kluwer Academic Publishers, 1993.
- [5] Parker, K.P., "Defect Coverage of Boundary Scan Test What does it mean when a Boundary-Scan Test Passes", ITC, pp. 181-189, 2003.
- [6] Jianbiao, P., "A Control-Chart Based Method for Solder Joint Crack Detection", Journals of Microelectronics and Electronic Packaging, Vol. 11, pp. 94-103, 2014.
- [7] Pan, J., Silk, J., "A Study of Solder Joint Failure Criteria",
- International Symposium on Microelectronics, pp. 694-702, 2011.

 Kwon, D., Azarian, M.H., Pecht, M.G., "Detection of Solder Joint Degradation Using RF Impedance Analysis", *Electronics Component and Technology Conference*, pp. 606-610, 2008.

 Kwon, D., Azarian, M.H., Pecht, M.G., "Detection of Solder Joint
- Failure Precursors in Tin-Lead and Lead-Free Assemblies using RF Impedance Analysis", Electronics Component and Technology
- Conference, pp. 663-667, 2009.
 [10] Widianto, Yotsuyanagi, H., Ono, A., Takagi, M., Roth, Z., Hashizume, M., "A built-in Electrical Test Circuit for Interconnect Test in Assembled PCBs", IEEE CPMT, pp. 201-204, 2012.

Bi-directional of a Built-in Test Circuit for Interconnect Defects in Assembled PCBs

	CIN	$I \wedge I$	TTV	RFP	ODT
UKI	יוורו	u A I	1 I Y	KFP	UKI

13% SIMILARITY INDEX

5%
INTERNET SOURCES

12% PUBLICATIONS

2%

STUDENT PAPERS

PRIMARY SOURCES

Umezu, Shoichi, Masaki Hashizume, and Hiroyuki Yotsuyanagi. "A built-in supply current test circuit for pin opens in assembled PCBs", 2014 International Conference on Electronics Packaging (ICEP), 2014.

2%

Publication

Yuki Ikiri, Hiroyuki Yotsuyanagi, Fara Ashikin Binti Ali, Shyue-Kung Lu, Masaki Hashizume. "A DfT Technique for Electrical Interconnect Testing of Circuit Boards with 3D Stacked SRAM ICs", 2023 IEEE CPMT Symposium Japan (ICSJ), 2023

2%

Publication

Three-Dimensional Integration of Semiconductors, 2015.

2%

Publication

informatika.umm.ac.id

2%

Shohei Suenaga, Masaki Hashizume, Hiroyuki Yotsuyanagi, Shyue-Kung Lu, Zvi Roth. "DFT

2%

for supply current testing to detect open defects at interconnects in 3D ICs", 2013 IEEE Electrical Design of Advanced Packaging Systems Symposium (EDAPS), 2013

Publication

- 6 www.ijirset.com
 Internet Source 2%
- Kosuke Nanbara, Akihiro Odoriba, Masaki Hashizume, Hiroyuki Yotsuyanagi, Shyue-Kung Lu. "Electrical interconnect test of 3D ICs made of dies without ESD protection circuits with a built-in test circuit", 2015 International 3D Systems Integration Conference (3DIC), 2015

Publication

Submitted to Universitas Mercu Buana Student Paper

1 %

Exclude quotes On

Exclude bibliography On

Exclude matches

< 1%



Digital Receipt

This receipt acknowledges that Turnitin received your paper. Below you will find the receipt information regarding your submission.

The first page of your submissions is displayed below.

Submission author: Artikel 3

Lailis Syafaah Assignment title:

Submission title: Bi-directional of a Built-in Test Circuit for Interconnect Defec...

Bi-directional_of_a_Built-in_Test_Circuit_for.pdf File name:

1.14M File size:

Page count: 4

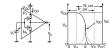
Word count: 2,429

Character count: 11,018

Submission date: 17-Jan-2024 11:00AM (UTC+0700)

Submission ID: 2272320684

Bi-directional of a Built-in Test Circuit for Interconnect Defects in Assembled PCBs



 $V_{ij} \le V_i \le V_{i2}$